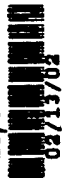


31000 U.S. PTO
10/075640



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PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

92-4-196

APPL NUM 10075640	FILING DATE 02/13/2002	CLASS 438	SUBCLASS	GAU 2818	EXAMINER D. V
**APPLICANTS: Nuttall Michael; Mercaldi Gary;					
**CONTINUING DATA VERIFIED: Yes DV THIS APPLICATION IS A DIV OF 09/770,909 01/26/2001					
** FOREIGN APPLICATIONS VERIFIED: None DV					
PG-PUB DO NOT PUBLISH <input type="checkbox"/>		RESCIND <input type="checkbox"/>			
Foreign priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no		35 USC 119 conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no		ATTORNEY DOCKET NO	
Verified and Acknowledged Examiners's initials DV				500803.02	
TITLE : Method for enhancing vertical growth during the selective formation of silicon, and structures formed using same					
U.S. DEPT. OF COM. / PAT. & TM-PTO-436L (Rev. 12-94)					

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NOTICE OF ALLOWANCE MAILED		Assistant Examiner	CLAIMS ALLOWED	
			Total Claims	Print Claim for O.G.
ISSUE FEE		Primary Examiner	DRAWING	
Amount Due	Date Paid		Sheets Drwg.	Figs. Drwg.
<input type="checkbox"/> TERMINAL DISCLAIMER		PREPARED FOR ISSUE	Application Examiner	
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